

Date: December 4, 2000
File No.: 1201-64722

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Xiuling Li et al.

Serial No.: 09/662,682

Filed: August 15, 2000

For: METAL-ASSISTED CHEMICAL
ETCH POROUS SILICON FORMATION
METHOD



I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this date.

12/14/00

Date
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Appr. February 20, 1998

Registration No. 35132

Attorney for Applicant

Group Art Unit: 1765

ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Completion of Filing Requirements

Transmitted herewith in response to the Office letter dated October 27, 2000 are:

- ☒ Declaration or oath for this application.
- ☒ Filing fee for this application.
- ☒ Assignment(s) of the invention to Board of Trustees of the University of Illinois.
- ☒ 1 Statement(s) of Small Entity Status.
- ☐ Other _____.
- ☒ A Check in the amount of \$429.00 to cover the filing fee and/or surcharge is enclosed.
- ☒ A check in the amount of \$40.00 to cover the fee for recording the assignment(s) is enclosed.
- ☐ Charge \$ _____ to Deposit Account No. 07-2069.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R. §§1.16-1.17, or credit any overpayment, to Deposit Account No. 07-2069. Should no proper amount be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

Suite 2500 -
300 S. Wacker Drive
Chicago, Illinois 60606
(312) 360-0080

GREER, BURNS & CRAIN, LTD.

By: 

Steven P. Fallon

Registration No. 35,132



UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICATION NUMBER	FILING/RECEIPT DATE	FIRST NAMED APPLICANT	ATTORNEY DOCKET NUMBER
09/662,682	09/15/2000	Xiuling Li	1201.64722

Greer Burns & Crain Ltd
Sears Tower
Suite 8660
233 South Wacker Drive
Chicago, IL 60606



FORMALITIES LETTER



OC000000005509631

Date Mailed: 10/27/2000

NOTICE TO FILE MISSING PARTS OF NONPROVISIONAL APPLICATION

FILED UNDER 37 CFR 1.53(b)

Filing Date Granted

An application number and filing date have been accorded to this application. The item(s) indicated below, however, are missing. Applicant is given TWO MONTHS from the date of this Notice within which to file all required items and pay any fees required below to avoid abandonment. Extensions of time may be obtained by filing a petition accompanied by the extension fee under the provisions of 37 CFR 1.136(a).

- The statutory basic filing fee is missing.
Applicant must submit \$ 690 to complete the basic filing fee and/or file a small entity statement claiming such status (37 CFR 1.27).
- Total additional claim fee(s) for this application is \$18.
 - \$18 for 1 total claims over 20.
- The oath or declaration is unsigned.
- To avoid abandonment, a late filing fee or oath or declaration surcharge as set forth in 37 CFR 1.16(e) of \$130 for a non-small entity, must be submitted with the missing items identified in this letter.
- The balance due by applicant is \$ 838.

*A copy of this notice **MUST** be returned with the reply.*


Customer Service Center

Initial Patent Examination Division (703) 308-1202

PART 2 - COPY TO BE RETURNED WITH RESPONSE

12/11/2000 YPQLITE1 00000046 09662682
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02 FC:203
03 FC:205
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